

In re Application of: IZUO et al.

Application No. 10/009,521

Filed: December 11, 2001

For: ELECTROCHEMICAL ETCHING METHOD AND APPARATUS AND PRODUCT MANUFACTURED THEREBY

Mail Stop Non-Fee Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

- ☐ Small entity status is claimed for this application under 37 CFR 1.27.
- ☐ Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- ☐ Other:
- ☐ Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY		
TIME EXTENSION PETITION FEE			none		\$ 0.00		\$ 0.00		
		subtract time extension fee previously paid		none		(\$ 0.00)		(\$ 0.00)	
CLAIM FEE		CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDIT. CLAIM FEE	RATE	ADDIT. CLAIM FEE
TOTAL			MINUS		=0	x 9=	\$	x 18=	\$
INDEPENDENT			MINUS		=0	x 43=	\$	x 86=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM					+ 145=	\$	+ 290=	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$	

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

*Jeffrey A. Wyand*  
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Date: *October 27, 2003*  
 JAW/tps  
 Amendment or ROA Transmittal (Revised 10/2/03)



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**OCT 28 2003**

**PATENT**  
Attorney Docket No. 401479

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

IZUO et al.

Application No. 10/009,521

Art Unit: 1742

Examiner: D. Valentine

Filed: December 11, 2001

For: ELECTROCHEMICAL ETCHING  
METHOD AND APPARATUS AND  
PRODUCT MANUFACTURED  
THEREBY

**RESPONSE TO OFFICE ACTION**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 4, 2003, please enter the following amendments and consider the following remarks.